

Claims

What is claimed is:

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1. A reformed wafer boat with a plurality of trenches, each trench
is used for placing a wafer and each trench and its adjacent
trench form an interval, the plurality of intervals between the
plurality of trenches are alternately composed of a first interval
10 and a second interval, the first interval is longer than the second
interval, and the wafers placed on the trenches at both ends of
the second interval are in form of back to back.
2. The reformed wafer boat of claim 1, wherein the reformed wafer
15 boat is used in a furnace process.
3. The reformed wafer boat of claim 1, wherein the reformed wafer
boat is used in a POCl_3 doping process.

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